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	Filing Date		2005-06-05	
	First Named Inventor Shi		hi Xue Dou	
	Art Unit		1796	
	Examiner Name	Mark	T. Kopec	
	Attorney Docket Num	oer	7383/83836	

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ZENG, XIANGHUI; POGREBNYAKOV, ALEXEJ V.; KOTCHAROV, ABMEN,; JONES, JAMES E.; XI, X.X.; LYSCZEK, ERIC M.; REDWING, JOAN M.; XU, SHENGYONG; LI, QI; LETTIERI, JAMES; SCHLOM, DARRELL G.; TIAN, WEI; PAN, XIAOQING and LIU, ZI-KUI, In situ epitaxial MgB2 thin films for superconducting electronic, Nature Materials, Vol. 1, September 2002, pgs. 1-4.						
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